



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
PTO-1449**

DOCKET NO.
10020/27902

SERIAL NO.
10/607,211

APPLICANT
FORREST et al.

FILING DATE
June 25, 2003

GROUP
1756

2815

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/ PUBLICATION NUMBER	PATENT/ PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
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EO	5,247,190	September 21, 1993	Friend et al.			
EO	5,256,205	October 26, 1993	Schmitt, III et al.			
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EO	2003/0230980	December 18, 2003	Forrest et al.			

FOREIGN PATENT DOCUMENTS

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						YES	NO

OTHER DOCUMENTS

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EO	U.S. Patent Application Serial No. 10/233,470 to Shtein et al., Filed September 4, 2002.
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EXAMINER	<i>Calvin D. Dity</i>	DATE CONSIDERED	9/15/04
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			